

Author	Review article	Citations	Journal	Year published	DOI or weblink
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Knez, Mato	ALD - A Versatile Tool for Nanostructuring		Material Matters	2008	https://www.sigmaaldrich.com/NL/en/technical-documents/technical-article/materials-science-and-engineering/chemical-vapor-deposition/ald-a-versatile
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Subramanian, Ashwanth; Tiwale, Nikhil; Nam, Chang-Yong	Review of Recent Advances in Applications of Vapor-Phase Material Infiltration Based on Atomic Layer Deposition	28	JOM	2019	https://doi.org/10.1007/s11837-018-3141-4
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